

Amendments to the Claims:

This listing of claims will replace all prior versions, and listings, of claims in the application:

Listing of Claims:

1. (Currently Amended) A piezoelectric/electrostrictive film type device comprising:

a ceramic substrate; formed of a ceramic, and

a piezoelectric/electrostrictive operation portion stacked on said substrate, said operation portion comprising in which at least one piezoelectric/electrostrictive layer having an upper exposed surface containing open pores and at least one pair of electrodes electrically connected to the said piezoelectric/electrostrictive layer; are stacked on the substrate,

wherein a highly water repellent surface is formed on a chemical structure of at least one of an outer surface of the said piezoelectric/electrostrictive layer and an upper electrode of said at least one pair of electrodes defines a highly water repellent surface.

2. (Currently Amended) ~~A~~ The piezoelectric/electrostrictive film type device according to claim 1,

~~—wherein said highly water repellent surface inhibits is modified in such an extent that infiltration of moisture infiltration into micro pores opened~~ said open pores in at least one of of the said outer upper exposed surface of the said piezoelectric/electrostrictive layer and the upper electrode of said at least one pair of electrodes, and/or into a gap between the substrate and the piezoelectric/electrostrictive layer is sufficiently inhibited.

3. (New) The piezoelectric/electrostrictive film type device of claim 1, wherein said highly water repellent surface inhibits moisture infiltration into a gap between said ceramic substrate and said piezoelectric/electrostrictive layer.

4. (New) The piezoelectric/electrostrictive film type device of claim 1, wherein said highly water repellent surface includes fluorine.